

Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>	Docket Number 146712001800	Application Number 2653 <small>09/18/01</small>
Applicant <p style="text-align: center;">Chung-Hee CHANG</p>		
Filing Date June 5, 2001		Group Art Unit 2653 <small>09/18/01</small>
Mailing Date June 5, 2001		

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09/18/01
06/05/01

U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate
<i>HL</i>	1.	7/1989	4,847,161	Rupp	—	—	
<i>HL</i>	2.	8/1997	5,660,930	Bertero et al.	—	—	
<i>HL</i>	3.	12/1998	5,854,727	Tanaka et al.	—	—	
<i>HL</i>	4.	7/1999	5,922,442	Lal et al.	—	—	
<i>HL</i>	5.	8/1999	5,933,297	Hoshiya et al.	—	—	
<i>HL</i>	6.	11/1999	5,995,338	Watanabe et al.	—	—	
<i>HL</i>	7.	11/1999	5,995,341	Tanaka et al.	—	—	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO

OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

Examiner Initials	Ref. No.	Title
<i>HL</i>	8.	Tang et al., "Microstructure and magnetic properties of CoCrPt/Cr films on ultrasmooth NiP/AlMg substrates, J. Appl. Phys. 79 (8), 15 April 1996
<i>HL</i>	9.	Lee et al.; "The effects of B2 structured underlayers on thin film magnetic recording media", 1997
<i>HL</i>	10.	Hsu et al., "The effect of processing conditions on CoCrPt/NiAl thin film", from Symposium L, Materials for High-Density Magnetic Recording, April 12-16, 1998 (abstract)

EXAMINER: GEORGE LETSCHER	DATE CONSIDERED: 12/23/03
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EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)

HT-01-003

Sequence Number

09/953,539

Applicant

Bernard Dieng et al.

Filing Date

09/17/01

Office Art Unit

2652

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	TITLE	CLASS	SUBCLASS	FILED DATE & APPROXIMATE
	6171693	1/9/01	Lubitz et al.	428	332	10/27/98
	6111784	8/29/00	Nishimura	365	173	9/16/98
	5898548	4/27/99	Dill et al.	360	113	10/24/97
	5650958	7/22/97	Gallagher et al.	365	173	3/18/96
	6198609	3/6/01	Barr et al.	360	322	11/9/98
	5668688	9/16/97	Dykes et al.	360	113	5/24/96

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Portion of Pages, Etc.)

<i>ff</i>	K. Nagasaka et al., "Giant magnetoresistance properties of a specular spin valve films in a current perpendicular to plane structure",
<i>ff</i>	Journal of Applied Physics, Vol. 89, No. 11, June 1, 2000, pp. 6943-6945.
<i>ff</i>	K. Bussman et al., "CPP Giant Magnetoresistance of NiFeCo/Cu/-
<i>ff</i>	CoFe/Cu Multilayers," IEEE Trans. on Magnetism, Vol. 34, No. 4,
	July 1998, pp. 924-926.

EXAMINER

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